

Notice of References Cited	Application/Control No. 10/776,256	Applicant(s)/Patent Under Reexamination CEMIC ET AL.	
	Examiner Arnel C. Lavarias	Art Unit 2872	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-4,964,692	10-1990	Prescott, Rochelle	385/117
*	B	US-2003/0002296	01-2003	Steiner et al.	362/560
	C	US-			
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	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
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	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	NONE				
	O					
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	NONE
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